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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: **Dou et al.**  
Appln. No.: **10/518,948**  
Filed: **December 17, 2004**  
For: **SUPERCONDUCTING  
MATERIAL AND METHOD  
OF SYNTHESIS**  
Group  
Art Unit: **1751**  
Examiner: **Not Yet Assigned**  

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Docket No.: **83836**  
Cust. No.: **22242**

Conf. No.: **3534**

**CERTIFICATE OF MAILING**

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this date.

9/8/06      L. Saf  
Date      Lilia I. Safonov  
Reg. No. 45,967

**STATUS INQUIRY**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

Inquiry is made as to the status of the above-referenced patent application. To date, the last correspondence received from the United States Patent and Trademark Office is the Notice of Publication of Application dated November 3, 2005.

Respectfully submitted,

FITCH, EVEN, TABIN & FLANNERY

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